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U.S. UTILITY Patent Application

PATENT NUMBER and
ISSUE DATE

APPL NUM 10036505	FILING DATE 01/07/2002	CLASS 250 358	SUBCLASS 201.2	GAU 2852 287	EXAMINER Aiken
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**APPLICANTS: Kim Jeong;

**CONTINUING DATA VERIFIED:

(none) TCC

** FOREIGN APPLICATIONS VERIFIED:

JAPAN 2001-006107 01/15/2001

TCC

PG-PUB DO NOT PUBLISH ☐

RESCIND ☐

Foreign priority claimed

☒ yes ☐ no

35 USC 119 conditions met

☒ yes ☐ no

Verified and Acknowledged Examiners's initials

TCC TCC

ATTORNEY DOCKET NO

025311-0113

TITLE : Wafer edge exposure apparatus, and wafer edge exposure method

U.S. DEPT. OF COMM./PAT. & TM-PTO-43EL (Rev. 12-94)

NOTICE OF ALLOWANCE MAILED		Assistant Examiner		CLAIMS ALLOWED	
				Total Claims	Print Claim for O.G.
ISSUE FEE		Primary Examiner		DRAWING	
Amount Due	Date Paid			Sheets Drwg.	Figs. Drwg.
<input type="checkbox"/> TERMINAL DISCLAIMER		PREPARED FOR ISSUE		Applicant's Examiner	
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